Product name:	Product code:
Laser Diffraction and Interference Training System	CMI-NP-1775



Description

Laser Diffraction and Interference Training System is a system with diode laser, slits, gratings and screen for diffraction and interference experiments.

Technical specification

Light source	LED and diode laser < 1 mW

Standard Accessories

- Lens set
- Fibre cable
- Experiment manual

The Laser Diffraction and Interference Training System is a system with diode laser, slits, gratings and screen for diffraction and interference experiments. It is designed for training in opto-electronic components, light-based measurement and optical devices combined with mechatronic control.

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Features

- Combines optics with sensors and actuators
- Suitable for optics, photonics and mechatronics courses
- Safe low-power laser and LED sources
- Digital readouts for easy data recording

Technical Specifications

Laser	650 nm, < 1 mW
Slits	Single, double, grating
Screen	White, scale 300 mm
Supply	230 V AC, 50 Hz, single phase
Optical bench	1000 mm rail